



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Karl-Heinz SCHUSTER

Application No.: 10/700,315

Filed: October 31, 2003

For: Interferometer Apparatus and
Method of Processing a Substrate Having
an Optical Surface

Customer No.: 20350

Confirmation No. 5458

Examiner: Hwa S. Lee

Technology Center/Art Unit: 2877

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed March 23, 2006, on the above-referenced application, please enter the following amendments and remarks:

Amendments to the Abstract begin on page 2 of this paper.

Amendments to the Claims are reflected in the Listing of Claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 13 of this paper.